



FORM PTO-1449	Atty. Docket No.: 169.12-0590	Application No.: 10/607,779
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	First Named Inventor: Huaqing Yin, et al.	
	Filing Date: June 27, 2003	Group Art: 3729

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<del>WJH</del> AO	"Advances in Dry Etching of GMR Materials", James M. Klemm and Edward W. Ostan., <a href="http://semiconductors.unaxis.com/en/chiponline_72dpi/issue4/c4p28_72.pdf">http://semiconductors.unaxis.com/en/chiponline_72dpi/issue4/c4p28_72.pdf</a> .
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EXAMINER:

DATE CONSIDERED:

3/12/06

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.